

L Number	Hits	Search Text	DB	Time stamp
-	0	oxidation with nitrided with gate with oxide with measur\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 14:03
-	1	(oxidation with nitrided with gate with oxide) and (measur\$3 with thickness)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/13 20:33
-	35	oxidation with nitrided with gate with oxide	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/13 20:33
-	8	(oxidation with nitrided with gate with oxide) and measur\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/13 20:36
-	0	(measur\$3 with thickness with oxide) and (nitidied with gate with oxide)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/13 20:37
-	13	(measur\$3 with thickness with oxide) and (nitrided with gate with oxide)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 11:35
-	6	ono and oxidiz\$3 and gate and oxide and nitrided and measur\$3 and thickness and ((predetermined or preset) with value)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/13 20:48
-	38	measur\$3 with thickness with ono	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 12:07
-	2	measur\$3 with thickness with nitrided with oxide	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 14:20
-	21	measur\$3 with thickness with nitrided	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 14:18
-	2	increas\$3 with thickness with reoxidized	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 14:19
-	418	nitrided with gate with oxide	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 14:21
-	14	(nitrided with gate with oxide) and measur\$3 and thickness and reoxidation	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 14:26
-	0	correlation same (oxide adj thickness) same (nitrogen adj concentration)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 14:28
-	5	correlation same oxide same thickness same nitrogen same concentration	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 15:16
-	9	correlation same oxide same thickness same nitrogen	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 15:23
-	365	measur\$3 same oxide same thickness same (nitrogen or nitrided)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 19:35

	112	(measur\$3 same oxide same thickness same (nitrogen or nitrided)) and 438/\$3.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 15:26
	102	((measur\$3 same oxide same thickness same (nitrogen or nitrided)) and 438/\$3.ccls.) and @ad<20011012	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 15:30
	3	((measur\$3 same oxide same thickness same (nitrogen or nitrided)) and 438/\$3.ccls.) and @ad<20011012) and reoxidized	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/14 15:30
	3	oxide same growth with rate with nitrogen with content	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 13:43
	97	(oxide or oxidation or oxidized) same growth with rate with nitrogen	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 13:48
	9	((oxide or oxidation or oxidized) same growth with rate with nitrogen) and measur\$3 with thickness	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 14:10
	68	(relation or correlation) same thickness same oxide same nitrogen	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 14:57
	21	((relation or correlation) same thickness same oxide same nitrogen) and measur\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 14:58
	18	((relation or correlation) same thickness same oxide same nitrogen) and measur\$3) and @ad<20011012	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 14:58
	299	determin\$5 same thickness same oxide same nitrogen	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 14:59
	144	(determin\$5 same thickness same oxide same nitrogen) and measur\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 15:00
	131	((determin\$5 same thickness same oxide same nitrogen) and measur\$3) and @ad<20011012	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 14:58
	33	determin\$5 with thickness with oxide with nitrogen	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 10:49
	17	(determin\$5 with thickness with oxide with nitrogen) and measur\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/16 15:07
	17	change with thickness with (oxide or oxidation or oxidized) with nitrogen	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 11:10
	62	measur\$3 and thickness and (oxide or oxidation or oxidized) and nitrogen and (reoxidation or reoxidized) and (oxynitride or ono)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 12:51
	56	(measur\$3 and thickness and (oxide or oxidation or oxidized) and nitrogen and (reoxidation or reoxidized) and (oxynitride or ono)) and @ad<20011012	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 13:01

	30	((measur\$3 and thickness and (oxide or oxidation or oxidized) and nitrogen and (reoxidation or reoxidized) and (oxynitride or onto)) and @ad<20011012) and (nitrogen same oxide same thickness) ((measur\$3 and thickness and (oxide or oxidation or oxidized) and nitrogen and (reoxidation or reoxidized) and (oxynitride or onto)) and @ad<20011012) and (nitrogen same oxide same thickness same (measur\$3 or determin\$5)) thickness same nitrided same before same after same (oxide or oxidation)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 13:06
	17		USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 14:02
	14		USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 19:22
	2213	(implant\$5 or dop\$3) with boron with gate with electrode	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 19:34
	1111	((implant\$5 or dop\$3) with boron with gate with electrode) and 438/\$3.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 19:35
	12	(measur\$3 same oxide same thickness same (nitrogen or nitrided)) and (((implant\$5 or dop\$3) with boron with gate with electrode) and 438/\$3.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/03/17 19:36
	15643	oxid\$5 with nitr\$4 with gate with oxide	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 12:07
	2903	(oxid\$5 with nitr\$4 with gate with oxide) with (thick\$4 or measur\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:48
	0	jp-2000311928-\$ did	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:11
	0	jp-200311928-\$ did	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 14:03
	0	jp-20000311928-\$ did	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 14:04
	0	jp-20311928-\$ did	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 14:05
	0	jp-00311928-\$ did	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:04
	2	5972804.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:05
	0	us-2003042432-\$ did	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:11
	0	us-20003042432-\$ did	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:11
	0	us-203042432-\$ did	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:15

-	1	059714.apn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:20
-	1	6639228.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:29
-	6	("5939763" "6060374" "6110784" "6245689" "6423601" "6475887").PN.	USPAT	2003/11/03 15:21
-	4	("5223443" "5604350" "5880013" "5904552").PN.	USPAT	2003/11/03 15:25
-	2	5254489.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:29
-	168	((oxid\$5 with nitr\$4 with gate with oxide) with (thick\$4 or measur\$4)) same boron	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:49
-	101	((((oxid\$5 with nitr\$4 with gate with oxide) with (thick\$4 or measur\$4)) same boron) and 438/\$3.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:50
-	82	((((oxid\$5 with nitr\$4 with gate with oxide) with (thick\$4 or measur\$4)) same boron) and 438/\$3.ccls.) and @ad<20011012	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:54
-	4	(((((oxid\$5 with nitr\$4 with gate with oxide) with (thick\$4 or measur\$4)) same boron) and 438/\$3.ccls.) and @ad<20011012) and reoxidation	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/03 15:55